

**Search Notes**

Application/Control No.

10/529,790

Examiner

RuiMeng Hu

Applicant(s)/Patent under  
Reexamination

SANO, TAKASHI

Art Unit

2618

**SEARCHED**

Class	Subclass	Date	Examiner
455	193.1-.3	2/23/2007	RH
455	195.1	2/23/2007	RH
455	197.2	2/23/2007	RH
455	161.1	2/23/2007	RH
455	160.1	2/23/2007	RH
455	181.1	6/22/2007	RH
455	182.1	6/22/2007	RH
455	182.2	6/22/2007	RH
455	182.3	6/22/2007	RH
455	231	6/22/2007	RH
455	344	6/22/2007	RH
455	192.2	6/22/2007	RH
455	185.1	6/22/2007	RH
455	186.1	6/22/2007	RH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
same as above		6/22/2007	RH

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST (USPAT, US-PGPUB, EPO, JPO, DERWENT, IBM_TDB) - See Search History Printout	2/23/2007	RH
consulted with Edan Orgad	6/22/2007	RH